



Form PTO-1449 (modified) List of Patents and Publications For Applicant's Information Disclosure Statement (Use several sheets if necessary)			ATTY. DOCKET NO: 5310-03000	SERIAL NO: 09/744,877			
			APPLICANT: Halimaoui et al.	CONFIRMATION NO.: 8711			
			FILING DATE: January 29, 2001	ART UNIT: 2822			
U.S. PATENT DOCUMENTS							
EXAM. INITIALS	REF. DES	DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	FILING DATE IF APPROPRIATE
CK	A1	5,021,354	6/1991	Pfiester			
CK	A2	5,106,768	8/1998	Kuo			
FOREIGN PATENT DOCUMENTS							
EXAM. INITIALS	REF. DES	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB CLASS	TRANSLATION. YES/NO
CK	A3	JP 61016530	1/1986	JP			Abstract
CK	A4	WO 97 41593	11/1997	WO			
OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)							
CK	A5	Soleimani et al.; "Formation of Ultrathin Nitrided SiO ₂ Oxides by Direct Nitrogen Implantation into Silicon"; <i>J. Electrochem. Soc.</i> , 1995, 42(10).					

EXAMINER: Christy Novack DATE CONSIDERED: 2/20/04

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the patent owner.